


INFORMATION DISCLOSURE STATEMENT 	Atty. Docket No.: 1063-US	Serial No.: 09/016,797
	Applicant: Michael F. Miller, et al.	Group: 4756 2873
	Filing Date: 12/10/2001	Examiner: Unknown

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if appropriate
T-F	AA	5,459,610	Oct. 17, 1995	Bloom, et al.	359	572	
	AB						
	AC						
	AD						
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	AF						

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FOREIGN PATENT DOCUMENTS

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							Yes	No
	AG							
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OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

T-F	AJ	Gui, C., et al., "Nanomechanical Optical Devices Fabricated with Aligned Wafer Bonding," MESA Research Institute, University of Twente, The Netherlands, pp. 482-487 (1998)					
	AK						
	AL						
	AM						
	AN						
	AO						

Examiner: <i>Jim Thompson</i>	Date Considered: <i>09/24/03</i>
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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.